

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

TI-29811

Patricia B. Smith, et al.

Examiner: Quoc D. Hoang

Serial No.: 09/975,639

Art Unit: 2818

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UEC 2 3 2004

Filed: 10/11/01

For: Hydrogen Plasma Photoresist Strip and Polymeric Residue Cleanup Process for Low Dielectric Constant Materials

NOTICE OF APPEAL FROM THE PRIMARY EXAMINER TO THE BOARD OF APPEALS

CERTIFICATION OF FASCIMILE TRANSMISSION

I hereby certify that the above correspondence is being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below:

| 12-23-04 | | |

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals claims 1, 5-13, 30-39 and 60-68 to the Board of Appeals from the decision dated October 1, 2004 of the Primary Examiner finally rejecting claims 1, 5-13, 30-39 and 60-68.

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Signature [Rule 191(b)]

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PAGE 2/2 * RCVD AT 12/23/2004 11:39:29 AM [Eastern Standard Time] * SVR:USPTO-EFXRF-1/1 * DNIS:8729305 * CSID:972 917 4417 * DURATION (mm-ss):00-50